

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of Applicants:

Haight et al.

Serial No.: 09/933,461

Filed: August 20, 2001

For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF  
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Date: July 30, 2003

Group Art Unit: 1725

Examiner: J. J. Johnson

Docket No.: YOR919980510US2

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this Request to Withdraw Notice of Abandonment (2 pages) and a copy of the RCE previously submitted and facsimile transmittal (5 pages) are being facsimile transmitted under Rule 37 CFR 1.61(d) to the U.S. Patent and Trademark Office to (703) 872-9310 on July 30, 2003.

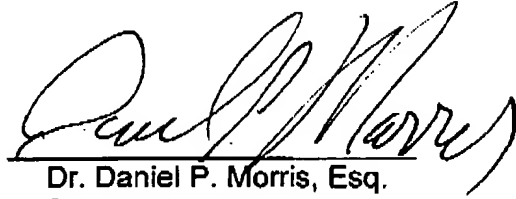
  
Dr. Daniel P. Morris, Esq.**REQUEST TO WITHDRAW NOTICE OF ABANDONMENT**

In the above-identified application, Applicants timely filed a Request For Continued Examination (RCE) June 10, 2003, the date on which the issue fee was due.

Enclosed is a copy of the RCE request and a report of facsimile transmission indicating it was received by the USPTO on June 10, 2003.

Respectfully submitted,

By:



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